



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No. 09/546,174

Application of: Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y. Wu, Water Lur and Shih-Wei Sun

Filed: April 11, 2000

Art Unit: 1711

Examiner: Sergent, Rabon A.

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- 2. Petition for Extension of Time with \$450 fee;
- 3. Certificate of Mailing by Express Mail; and
- 4. Return postcard

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